

# IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Appln. Ser. No.:	Filed:	Inventor(s):	Atty Dkt:
N/A	Herewith	ZETTEL	0499-036
Title: <i>CATALYTIC MONOLITH SUPPORT SYSTEM WITH IMPROVED THERMAL RESISTANCE AND MECHANICAL PROPERTIES</i>			
Examiner: N/A			Art Unit: N/A

# 5-14-02

JC879 U.S. PTO  
 10/04/02  
 01/10/02

## PATENT APPLICATION

Asst. Comm'r for Patents  
Washington, D.C. 20231-0001

## INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, please enter and consider for the above-identified application the documents listed on the attached Form PTO-1449.

Applicants maintain that the subject invention is novel and non-obvious over the above references, and that none of the above references disclose or suggest the invention claimed in the subject application.

No fee is believed to be required for entry and consideration of the present INFORMATION DISCLOSURE STATEMENT, since it is being submitted before the mailing of the first Office Action on the merits pursuant 37 C.F.R. § 1.97(b)(3).

### CERTIFICATE OF MAILING OR TRANSMISSION - 37 CFR 1.8

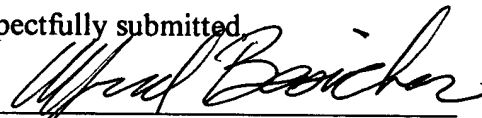
I hereby certify that I have a reasonable basis that this paper, along with any referred to above, (i) are being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231, or (ii) are being transmitted to the U.S. Patent & Trademark Office in accordance with 37 CFR § 1.6(d).

DATE: January 9 '01

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Respectfully submitted,



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Encl: Form PTO-1449 and  
references cited therein.

